Form PTO 1449		U.S. DEPARTMENT (ATTY DOCKET NO.			SERIAL NO.		
(Modified)		PATENT AND TRAD	EMARK OFFICE	218347US0SRD			NEW APPLICATION		
APPLICANT									
LISTOF	KEFE	RENCES CITED BY APF	PLICANT	Tomoyuki MAEDA					
			FILING DATE			GROUP			
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U.S. PATENT DOCUMENTS									
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	N/	AME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE	
	AA								
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<i>y</i>		DOCUMENT DATE COUNTRY				TRANSLATION YES NO			
1/16	AO	9-320847	12/12/97	Japan			1 23	X	
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	OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)								
148	AW	O. KITAKAMI, et al. "Low-Temperature Ordering of L1 ₀ -CoPt Thin Films Promoted by Sn, Pb, Sb, and Bi Additives", APPLIED PHYSICS LETTERS, VOLUME 78, NUMBER 8, February 19, 2001, pgs. 1104-1106							
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	AY			<u> </u>				· .	
	AZ						Additional References sheet(s) attached		
Examiner Min Aug Date Considered 4/1/03									
*Examiner: In conformance	*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								